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Inventor	Table 1, 2000
Assignee	Microp Technology, Inc.
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Title: Methods of Removing at Least Some of	a Material From a Semiconductor Substrate

Assistant Commissioner for Patents Washington, D.C. 20231

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Dated: 4-24-02	By: <u>Jame M. White</u> Jalme M. White
	Jájme M. White
	Telephone No. (509) 624-4276
	Facsimile No. (509) 838-3424

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